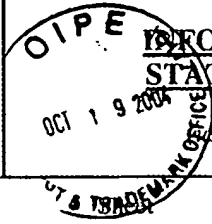


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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Use as many sheets as necessary)

Complete if Known

Application Number	10/734,623
Confirmation Number	2006
Filing Date	December 15, 2003
First Named Inventor	David SHAFER
Art Unit	2873
Examiner Name	Not Yet Assigned

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Attorney Docket Number Q79028

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Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	
		Number	Kind Code ² (if known)			
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W.C.		US 5,831,770 (Corresponds to EP 0 770 895)		11/03/1998	Matsuzawa et al.	359/649
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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
W.C.		DE	197 26 058	A1	01/02/1998	Nikon Corporation	Abstract
W.C.		DE	195 35 392	A1	03/27/1997	Carl Zeiss	Abstract
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NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
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Examiner Signature

Date Considered

6/27/05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Applicant's unique citation designation number (optional). ² See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or in the comment box of this document. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial



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Complete if Known

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 First Named Inventor David SHAFER
 Art Unit 2873
 Examiner Name Not Yet Assigned
 Attorney Docket Number Q79028

Sheet 1 of 1

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Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
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Examiner Signature

W.C.

Date Considered

6/27/05